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SEP 27 2004

DATE OF DEPOSIT

9/27/04

OFFICE OF PETITIONS

9281-4241

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Appln. of: Akira Nakano et al.

Appln. No.: 10/043,739

Filed: January 9, 2002

For: Plasma Processing Apparatus And
System, Performance
Validation System And Inspection
Method Therefor

Attorney Docket No: 9281-4241

Examiner: MaGee, Christopher

Art Unit: 2653

REQUEST FOR CONTINUED EXAMINATION (37 CFR § 1.114)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

Dear Sir:

Applicant requests continued examination under 37 CFR § 1.114.

Applicant is:

a small entity, verified statement is:

attached

already filed

other than small entity

The fee set forth in § 1.17(e) must be filed along with this request:

Attached is a check for the § 1.17(h) fee.

Charge the § 1.17(e) fee to Deposit Account No. 23-1925.
A duplicate copy of this request is attached.

A submission must be filed along with this request. The following submission(s) is(are) filed herewith:

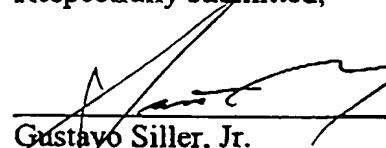
An Information Disclosure Statement

Case No. 9281-2458

- Petition to Withdraw From Issue Under 37 CFR § 1.313
- An Amendment to the written description, claims, or drawings
- New Arguments and/or New Evidence in Support of Patentability
- Other: Amendment

- A petition and fee for an extension of the time is enclosed herewith.
- A check in the amount of \$770 and \$130 to cover the RCE filing fee and Petition Fee is enclosed.
- Charge any additional fee required or credit for any excess fee paid to Deposit Account No. 23-1925. A duplicate copy of this request is attached.

Respectfully submitted,

Dated: September 27, 2004

Gustavo Siller, Jr.
Registration No. 32,305
Agent for Applicants

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